,	Se	arc	rch Notes					

Application/Control No.	Applicant(s)/Patent under Reexamination
10/532,632	CHEN ET AL.
Examiner	Art Unit
Emmanuel Bayard	2611

SEARCHED				
Class	Subclass	Date	Examiner	
375	299	7/10/2007	EB	
375	267	7/10/2007	EB	
375	150	7/10/2007	EB	
375	349	7/10/2007	EB	
375	347	7/10/2007	ЕВ	
375	295	7/10/2007	EB	
375	265	7/10/2007	ЕВ	
370	335	7/10/2007	EB	
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INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
375	295	7/10/2007	EB	
375	265	7/10/2007	EB	

SEARCH NOT (INCLUDING SEARCH	ES STRATEGY)
	DATE	EXMR
East	7/10/2007	EB
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